The Effects of Preheating Millisecond Anneals on Dopant Activation in Silicon

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	22 nd International Conference on Ion Implantation Technology
fits to teff calculated in each of the four heating stages shown in Fig.	e maximum carrier concentrations)(No effective times,et. R ² is shown for the 1 (PH, FH, FC and SC) and for the whole annotative to 0.5 and 6eV. The ivation in the four implant types (As1, As3,3P.1Tatredfigure also includes from

TABLE II. COMPARISON OF THE CHARACTERISTICS OF THE ANNEALS USED TO EXPLORE THE EFFECT OF PREHEAT THE GWAS CALCULATED FOR E_A =1.9eVin the SLow cooling Stage d_{reg} was calculated for the preheat TRAMP-up Stages

		As1			As3			P1			P3		
Recipe	T _{peak} (°C)	t _{eff} (s)	d _{reg} (nm)	T _{peak} (°C)	t _{eff} (s)	d _{reg} (nm)	T _{peak} (°C)	t _{eff} (s)	d _{reg} (nm)	T _{peak} (°C)	t _{eff} (s)	d _{reg} (nm)	
NPMSA	1175.0	4.1	19	1176.	8 4.0	19	117	6.3 4	.0 1	9 11	82.4	4.1	19
PSMSA	1173.3	4.0	105	1167	.7 4.0) 10	5 117	3.9 4	.0 1	05 11	68.3	4.0	105
BSH	800.6	3.7	36	800.1	3.7	33	801	.1 3.	.8 3	3 80	1.4	3.8	34
Spike	801.5	3.8	204	801.	4 3.8	20	3 -	-	_	-	-	-	
HTIMSA	1177.0	7.7	88	1177.	4 7.8	90	1178	3.8 7.	.9 9	0 116	9.1	7.7	90

Table II also includes data for the high-TMSA (HTIMSA). This case was included for comparison here, because of all the recipes in Table I, HTIMSA gave the lowest N_A . This might be expected from the greater deactivation expected from a higheron but the preheating